

Mirror

LCGT

Technical advisory committee

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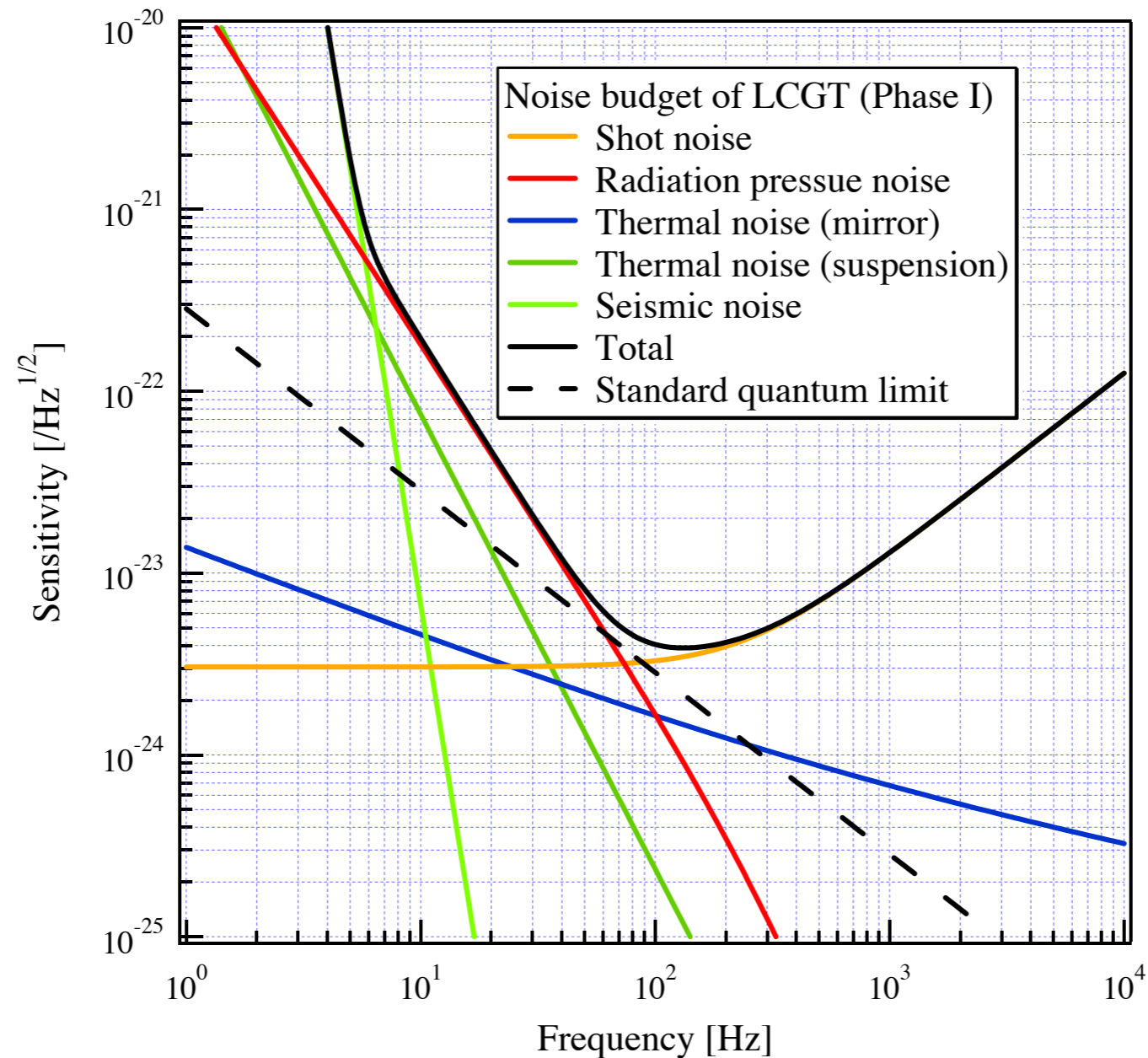
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- Summary of the mirror

LCGT mirror

- LCGT uses sapphire mirrors.
- Sapphire: $\Phi 250 \times 150$ 、30kg.
- Coating: $\text{SiO}_2/\text{Ta}_2\text{O}_5$.
 - Front mirror 99.6% reflectance.
 - End mirror 99.995% reflectance.
- End mirror has curvature of several km.
- Cooled at 20K.

Mirror thermal noise

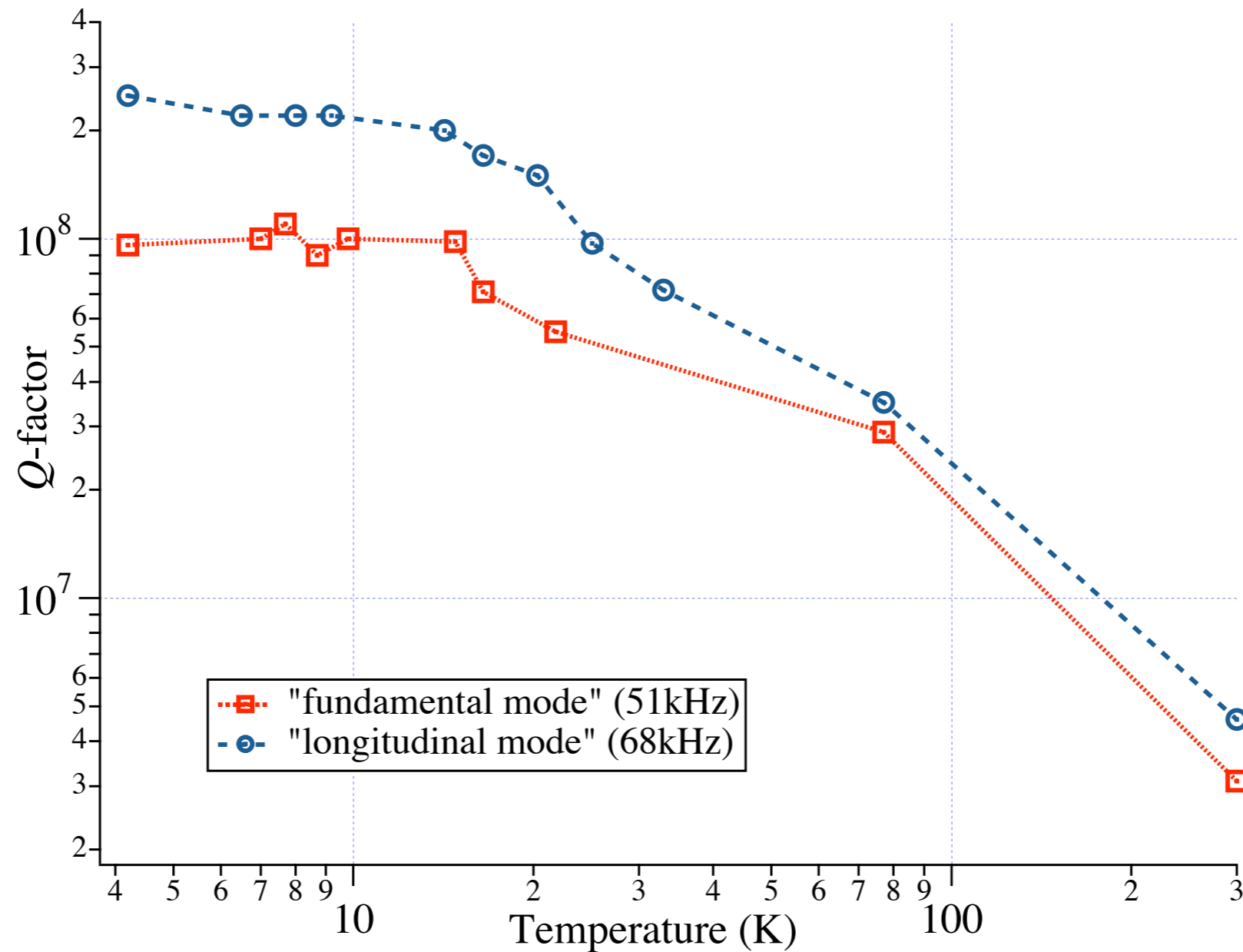


Cryogenic cooled sapphire mirror makes possible low mirror thermal noise level.

Mirror thermal noise 2

- There are three kinds of mirror thermal noise.
- Structure damping in the substrate.
 - Low T and high mechanical Q .
- Structure damping in the coating.
 - Low T and low Dissipation.
- Thermoelastic damping in the substrate.
 - Low T and thermal expansion ratio.

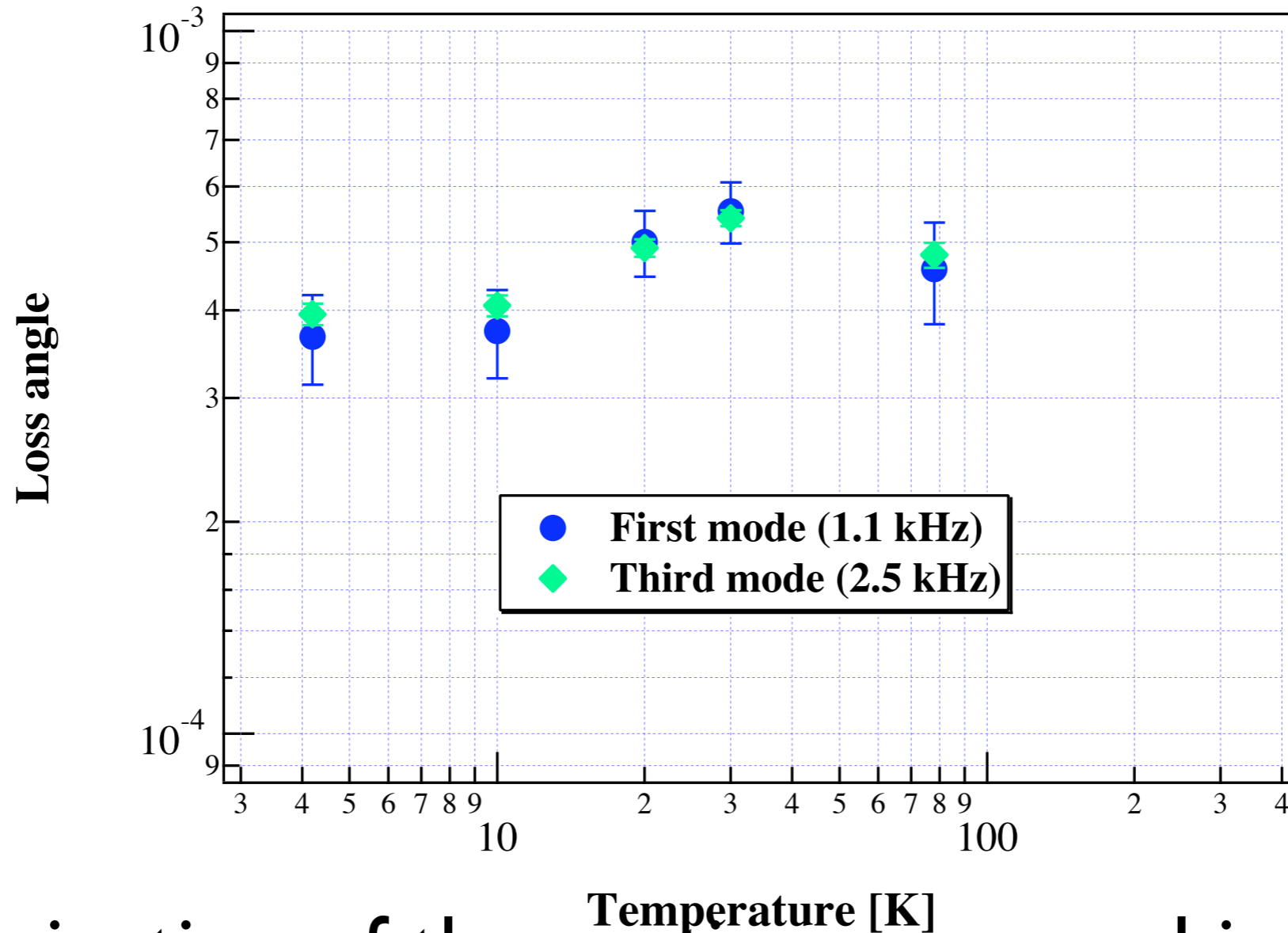
Mechanical Q



T. Uchiyama

Mechanical Q of sapphire cylinder.
Reached to 10^8

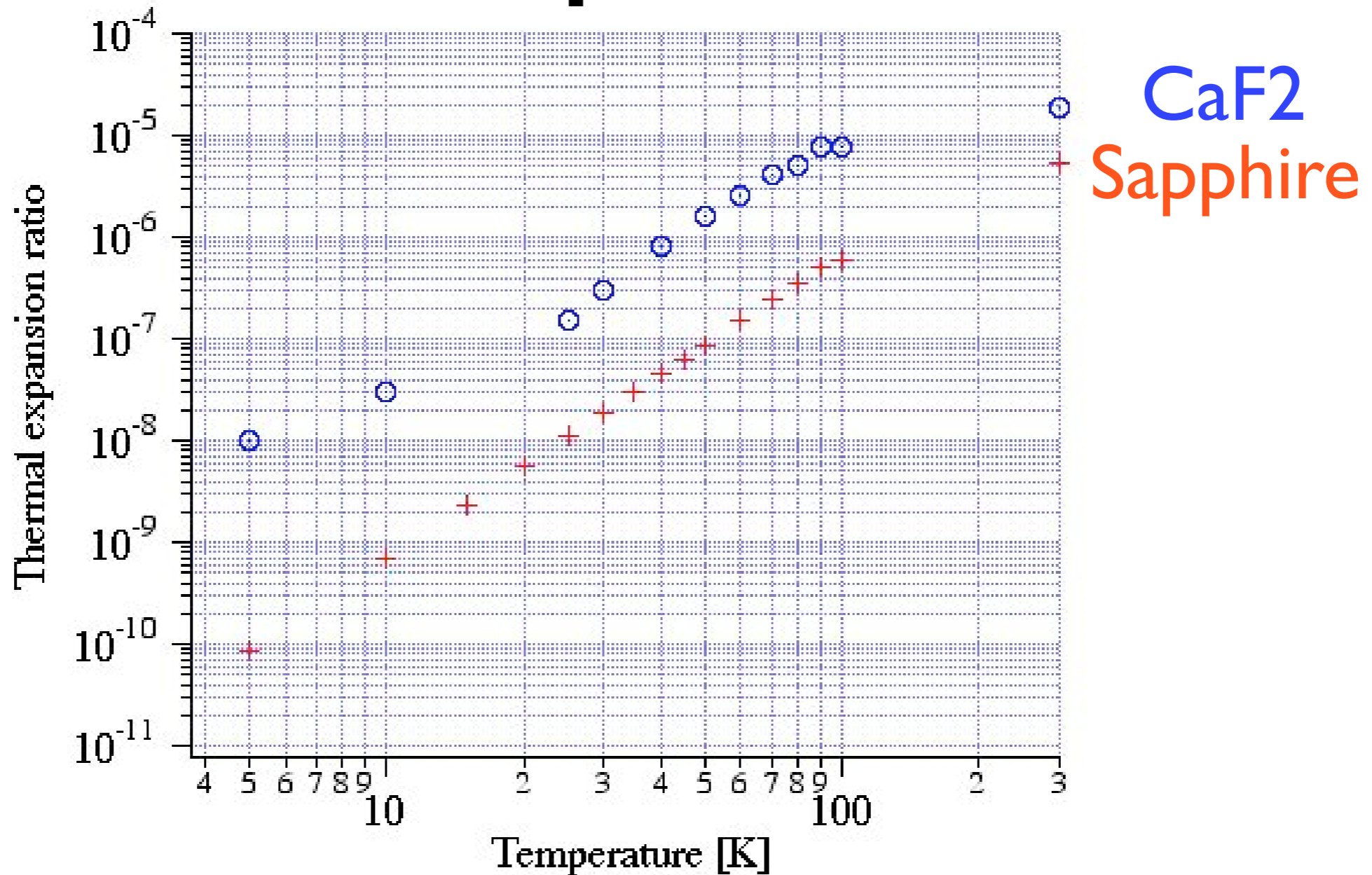
Dissipation



K.Yamamoto

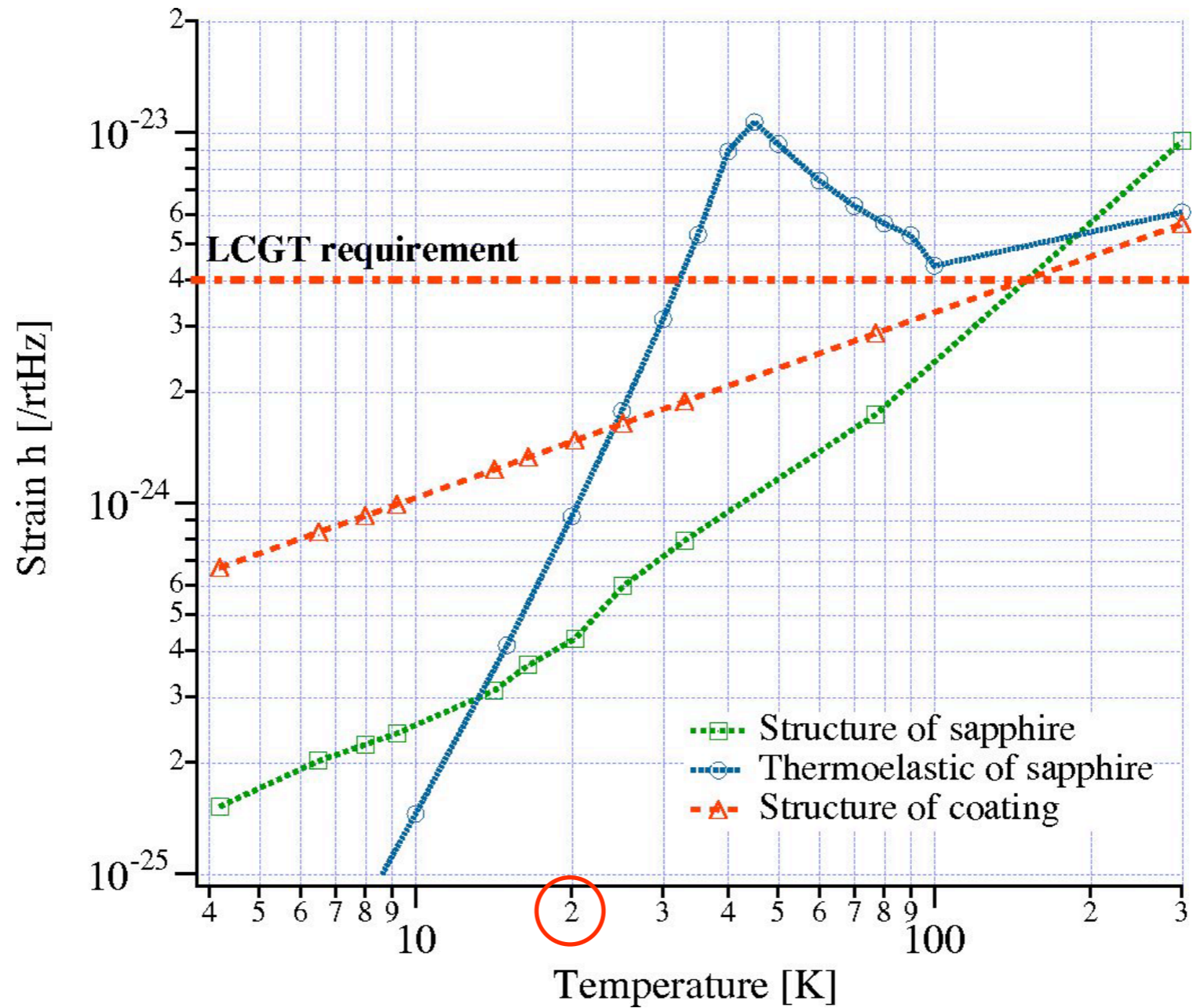
Dissipation of the coating on a sapphire disk.
Temperature independent.

Thermal expansion ratio



Sapphire is very small expansion ratio in cryogenic temperature.

Cryogenic



Temperature dependence of the mirror thermal noise at 100Hz
20 K is the target temperature.

Thermal lensing

- Thermal lensing effect
 - High power laser makes temperature gradient in the mirror.
 - Refraction index changes with temperature.
 - Refraction index gradient will appear. It act as a lens.
- Sapphire mirror
 - High thermal conductivity: $4 \times 10^3 \text{W/m/K}$ at 20K.
 - Low temperature dependence of refraction index:
 - $\beta < |9 \times 10^{-8}| / \text{K}$ at 20K_(T.Tomaru).
- 10000 times smaller than in room temperature !!

Optical property

- absorption -

- Laser absorption is important factor for cooling.
- LCGT target
 - Substrate: 20ppm/cm \rightarrow 250mW
 - Coating: 1 ppm \rightarrow 40mW
- Current status
 - Substrate : 40 - 60ppm/cm (CSI Hemex white grade)
 - 20 - 30ppm/cm (use annealing) (R. K. Route et al., LIGO-G040084-00-Z)
 - Coating: 1 ppm (R. K. Route et al., LIGO-G030023-00-Z)

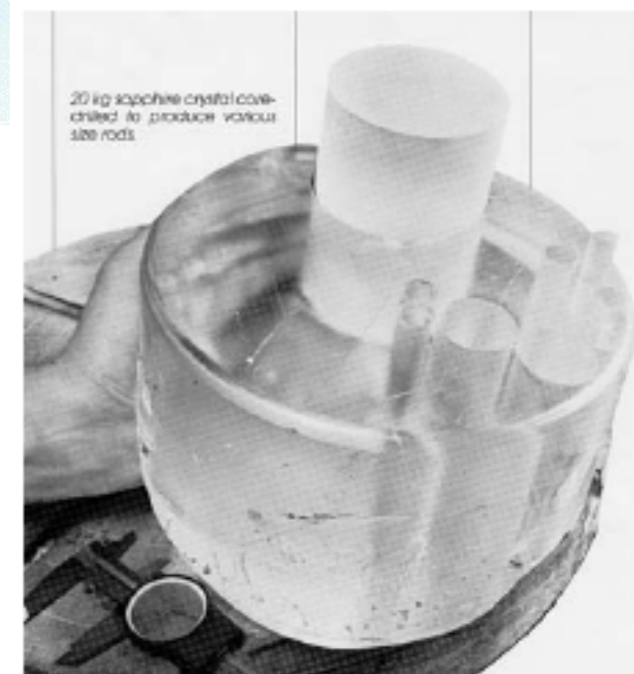
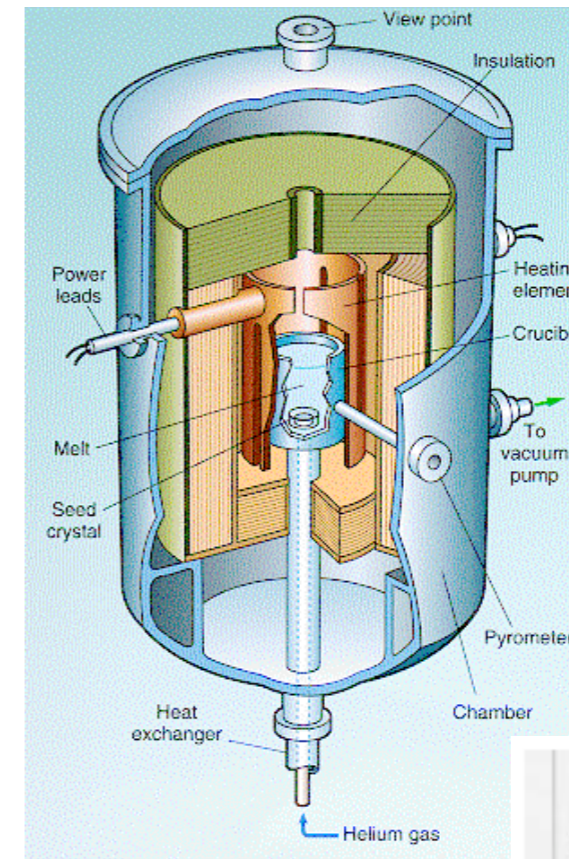
Absorption is close to the target value even now.

Our current cryogenic design is possible to cool the mirror, even if the substrate has 60ppm/cm absorption.

Make the mirror I

- substrate -

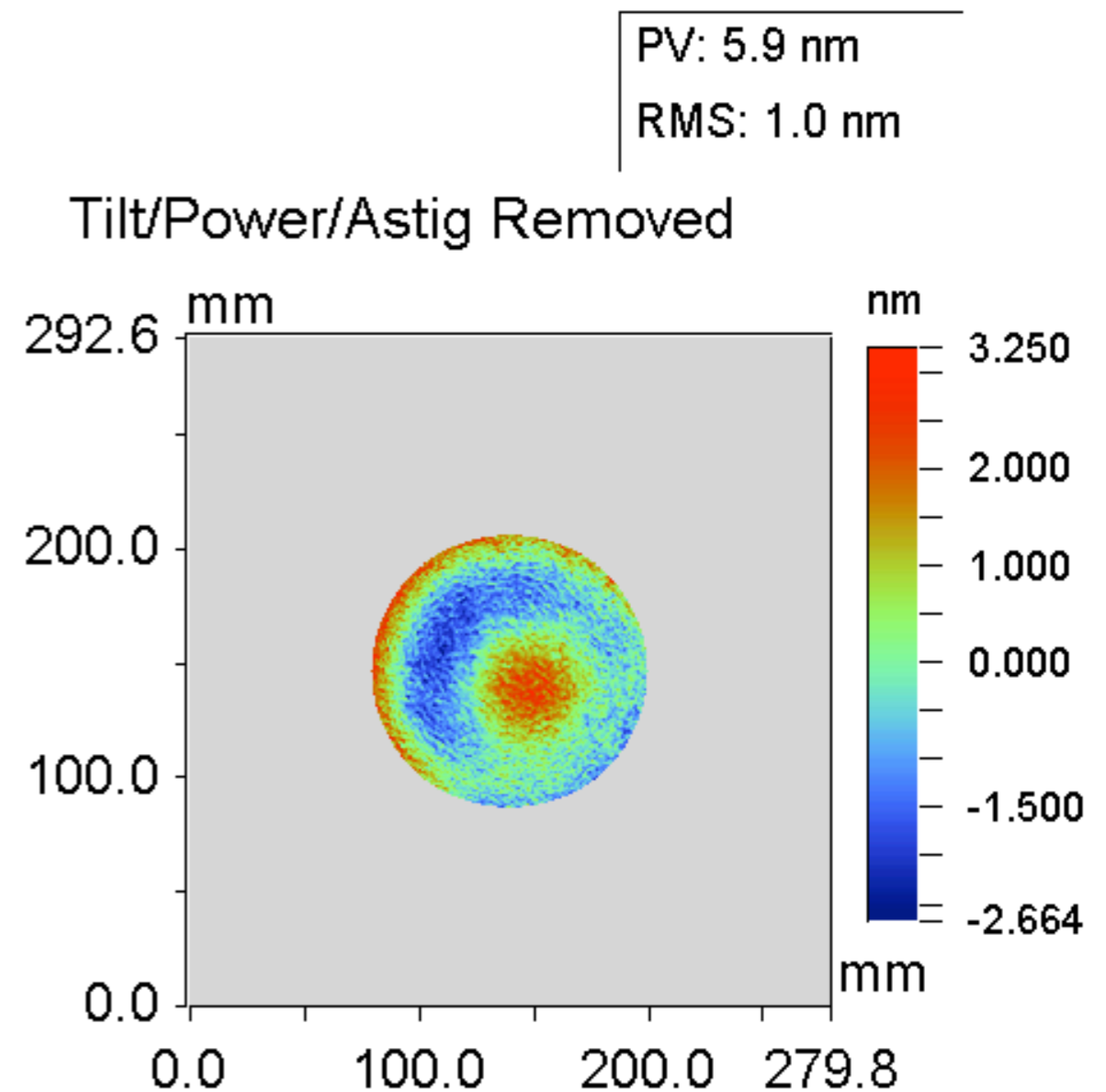
- Substrate ($\Phi 250 \times 150$).
- Crystal Systems Inc.
- Heat Exchanger Method.
- $\Phi 330$, 65kg sample is possible.
- Effort for the quality up is still valuable.



Make the mirror 2

- polish -

- CSIRO or Canon Inc.
- Micro roughness $< 1\text{\AA}$
- RMS 1.0nm.
- Curvature of 9000m has been made for TAMA power recycling mirror (fused silica).



CSIRO sapphire polish

(G. Billingsley et al., LIGO-G030007-01-D)

Make the mirror 3

- coating -

- Japan Aviation Electronics Industry Ltd.
- Ion beam sputtering machine.
- $\Phi 250$ sample is possible.
- Finesse of 25000 has been achieved (fused silica).
- Low loss and high reflective coating is possible.

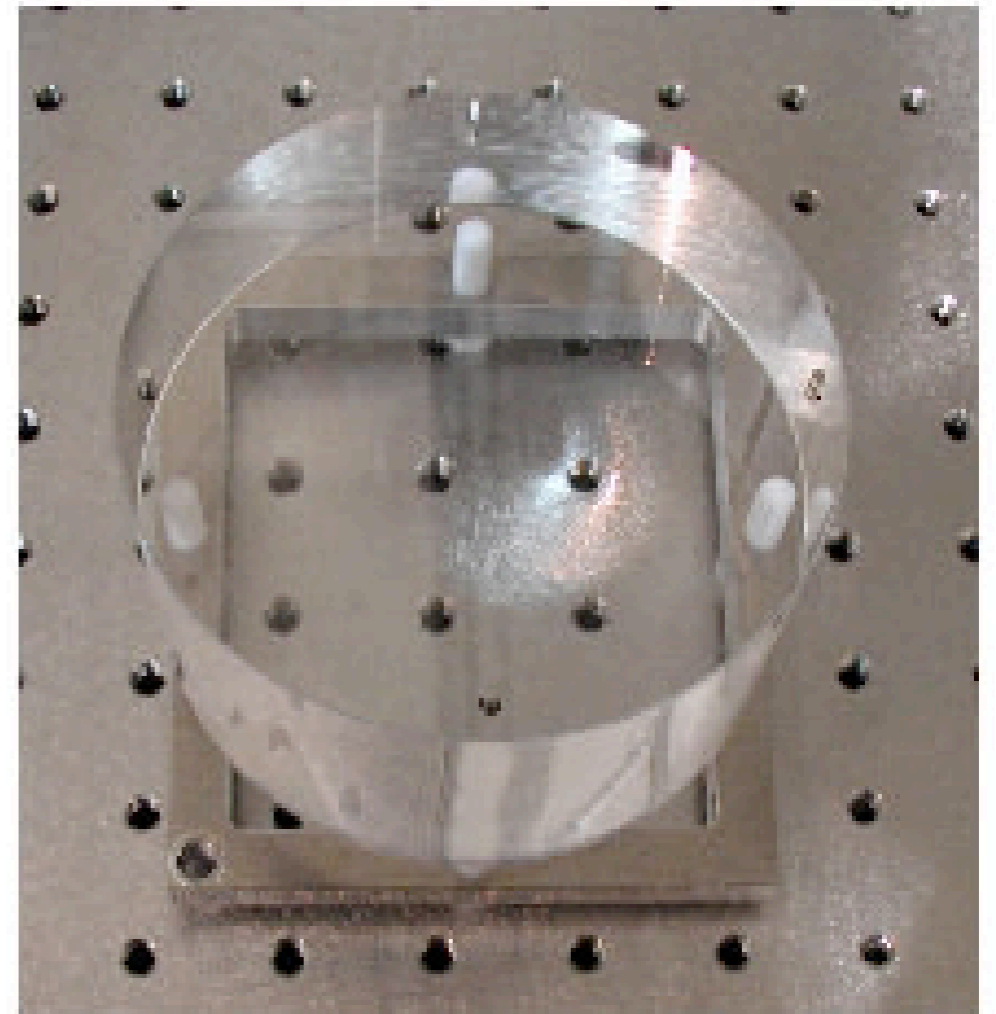


IBS at NAO

Make the mirror 4

- Sapphire mirror for CLIK -

- Cryogenic Laser Interferometer in Kashiwa.
- 7m Fabry-Perot cavity.
- Sapphire mirror $\Phi 100 \times 60$ (CSI).
- $R=30286\text{mm}$ (30m requested) has achieved (Canon).
- Waviness $< \lambda/4$.
- Roughness $< 10 \text{ \AA}$.
- Finesse of 3142 and reflectivity of 99.9% have achieved.



Summary of the mirror

- LCGT uses the sapphire mirror.
- The mirror thermal noise is much lower than the design sensitivity, when the mirror is cooled at 20K.
- Technical issues for realizing the LCGT mirror are overcome in study of the past projects.
- We are ready for making the mirror.